

**Notice of References Cited**

Application/Control No.

09/827,056

Applicant(s)/Patent Under

Reexamination

LIU ET AL.

Examiner

Thomas J. Mage

Art Unit

2811

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,355,527	03-2002	Yai-Fen Lin et al.	438/265
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	Tomohisa Mizuno, Shizuo Sawada, Yoshikazu Saitoh, and Takeshi Tanaka, "Hot-Carrier Injection Suppression Due to the Nitride-Oxide LDD Spacer Structure," IEEE Trans. on Electron Devices, Vol.38, No. 3, (1991), pp. 584-591.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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	K	US-			
	L	US-			
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